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INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet 1 of 1 Attorney Docket Number TOW-099US

10/15/3143

Application Number	Not Yet Assigned
Filing Date	Herewith
First Named Inventor	Seiji Sugiura
Art Unit	Not Yet Assigned
Examiner Name	Not Yet Assigned

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
/K.H.	A1	5,998,055	12-07-1999	Kurita, et al.	

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				
	A2	EP 0 459 940 A1	12-04-1991	Institute of Gas Technology		
	A3	JP 5-190187	07-30-1993	Institute of Gas Technology		
	A4	WO 92/04740 A1	03-15-1992	Allied Signal Inc.		
	A5	JP 6-502057	03-01-1994	Allied Signal Inc.		
/K.H.	A6	JP 6-163063	06-10-1994	Institute of Gas Technology		abst
	A7	JP 08-222237	08-30-1996	Aisin AW Co. Ltd.		abst
	A8	EP 0 521 830 B1	01-29-1997	Institute of Gas Technology		
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/K.H.	A11	JP 2000-164230	06-16-2000	Aisin Seiki Co. Ltd.		
	A12	JP 2000-320440	11-24-2000	Mitsubishi Heavy Ind. Ltd.		
	A13	JP 2002-530836	09-17-2002	Institute of Gas Technology		

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹Applicant's unique citation designation number (optional). ²See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²

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¹Applicant's unique citation designation number (optional). ²Applicant is to place a check mark here if English language Translation is attached.

Examiner Signature	/Kwang Han/ (05/21/2008)	Date Considered	05/21/2008
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ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /K.H./